

Form PTO-1449 Modified

Docket No.
CFMT-0255Serial No.
10/074,516List of Patent and Publications
Cited by Applicant
(Use several sheets if necessary)Applicant
Steven VerhaverbekeU.S. Department of Commerce
Patent and Trademark OfficeFiling Date
February 13, 2002Group
1762- 1763

U. S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>AW</i>	AZ	6,245,158 B1	06/12/01	Verhaverbeke	134	10
<i>AW</i>	BA	6,261,845 B1	07/17/01	Verhaverbeke, et al.	436	55
<i>AW</i>	BB	09/478,051 ^{6,517,636}	01/05/00 ^{2/11/03}	Verhaverbeke	134	002
<i>AW</i>	BC	09/564,358 ^{6,378,544}	04/19/00 ^{4/30/02}	DiBello, G.N.	137	068,250
<i>AW</i>	BD	09/574,790	05/19/00	Verhaverbeke		
<i>AW</i>	BE	09/727,661 ^{US 2002/0046717}	12/01/00 ^{6/6/02}	Verhaverbeke, et al.		
<i>AW</i>	BF	09/805,348 ^{6,491,763}	03/13/01 ^{12/18/02}	Verhaverbeke, S. et al.		
<i>AW</i>	BG	09/930,009 ^{US 2002/0104552}	08/15/01 ^{3/8/02}	Bay, et al.	134	018

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Examiner Initial		Document No.	Date	Country	Translation YES NO	
<i>AW</i>	BH	EP 0 233 184 B1	08/26/87	EPO		

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Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>AW</i>	AP	4,917,123	04/17/90	McConnell, et al.	134	95
	AQ	4,984,597	01/15/91	McConnell, et al.	134	95
	AR	5,383,484	01/24/95	Thomas, et al.	134	184
	AS	5,569,330	10/29/96	Schild, et al.	131	1
	AT	5,571,337	11/05/96	Mohindra, et al.	134	25.4
	AU	5,972,123	10/26/99	Verhaverbeke	134	3
	AV	6,032,682	03/07/00	Verhaverbeke	134	1.3
	AW	6,135,522	10/17/00	Verhaverbeke, et al.	134	26
	AX	6,143,087	11/07/00	Walter	134	1
<i>AW</i>	AY	6,165,912	12/26/00	McConnell, et al.	438	758

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EXAMINER <i>Alta Olan</i>				DATE CONSIDERED <i>7/23/03</i>		

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Examiner Initial		Document No.	Date	Name	Class	Subclass
<i>AW</i>	AF	4,577,650	03/25/86	McConnell	134	59
	AG	4,633,893	01/06/87	McConnell, et al.	134	95
	AH	4,738,272	04/19/88	McConnell	134	59
	AI	4,740,249	04/26/88	McConnell	134	25.4
	AJ	4,778,532	10/18/88	McConnell, et al.	134	10
	AK	4,795,497	01/03/89	McConnell, et al.	134	18
	AL	4,856,272	08/15/89	Putman, et al.	60	39.02
	AM	4,856,544	08/15/89	McConnell, et al.	134	95
	AN	4,899,767	02/13/90	McConnell, et al.	134	56R
<i>AW</i>	AO	4,911,761	03/27/90	McConnell, et al.	134	11

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<i>See</i>	35	4,206,541	06/10/80	Marciniec	29	611
<i>See</i>	36	5,851,303	12/22/98	Hwang, et al.	134	3
<i>See</i>	37	5,949,126	09/07/99	Dawson, et al.	257	513
<i>See</i>	38	6,083,840	06/04/00	Mravic, et al.	438	693
<i>See</i>	39	09/209,101 ^{6,495,011}	12/10/98 12/17/02	Verhaverbke, et al.	422	028
<i>See</i>	40	09/253,157	02/19/99	Verhaverbeke, et al.		

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 List of Patent and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce Patent and Trademark Office		Applicant Steven Verhaverbeke	
		Filing Date February 13, 2002	Group 1762- 1763
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
<i>See</i>	AA	Burkman, D.C. et al., "Aqueous Cleaning Processes", Chapter 3, Handbook of Semiconductor Wafer Cleaning Technology , (edited by Werner Kern, Published by Noyes Publication Parkridge, New Jersey, 1993, 111-151	
<i>1</i>	AB	Horiki, H. et al., "Wet Etch Cleaning", <i>Ultraclean Technology Handbook</i> , Ultra Pure Water, Volume 1, Chapter 3, 805-819	
<i>1</i>	AC	Werner Kern, et al., <i>Thin Film Processes</i> , "Chemical Etching", 1978, 401-496	
<i>1</i>	AD	Werner Kern, "Overview and Evolution of Semiconductor Wafer Contamination and Cleaning Technology", Chapter 1 , 3-67	
<i>See</i>	AE	Verhaverbeke, S. et al., "Scientific rinsing and drying on macro and microscale", <i>Semiconductor Pure Water and Chemicals Conference</i> , Balazs, M.J. (Ed.), Santa Clara, Ca., March 4-7, 1996, 14 pages	
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